



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masahiro YASUKAWA

Group Art Unit: 2813

Application No.: 10/734,246

Examiner: T. Nguyen

Filed: December 15, 2003

Docket No.: 117838

For: METHOD FOR MANUFACTURING ELECTRO-OPTICAL SUBSTRATE, METHOD FOR MANUFACTURING ELECTRO-OPTICAL APPARATUS, AND ELECTRO-OPTICAL APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

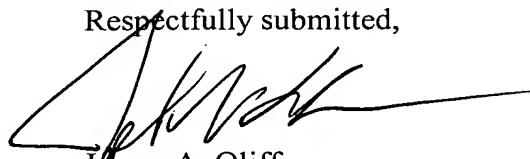
In reply to the November 16, 2004 Restriction Requirement, Applicant provisionally elects Group I, claims 1-8, drawn to a method for manufacturing an electro-optical substrate, classified in class 438, subclass 149, with traverse.

It is also respectfully submitted that the subject matter of all claims 1-9 is sufficiently related that a thorough search for the subject matter of any one Group of claims would encompass a search for the subject matter of the remaining claims. Thus, it is respectfully submitted that the search and examination of the entire application could be made without serious burden. See MPEP §803 in which it is stated that "if the search and examination of an entire application can be made without serious burden, the examiner must examine it on the merits, even though it includes claims to independent or distinct inventions" (emphasis added). It is respectfully submitted that this policy should apply in the present application in

order to avoid unnecessary delay and expense to Applicant and duplicative examination by the Patent Office.

Thus, withdrawal of the Restriction Requirement is respectfully requested.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

John S. Kern
Registration No. 42,719

JAO:JSK/kap

Date: December 16, 2004

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
--